



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Thad G. Walker,  
Bien Chann,  
Ian A. Nelson ✓

Date: July 15, 2003

Docket No.: 032026:0486

Serial No.: 09/706,088 ✓

Group Art Unit: 2815

Filed: November 3, 2000 ✓

Examiner: Matthew C. Landau

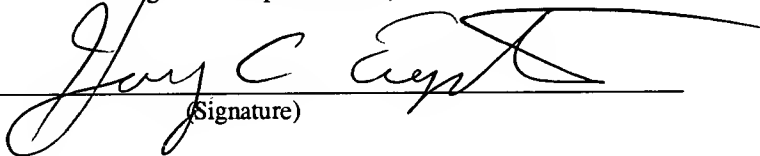
For: **FREQUENCY-NARROWED HIGH POWER DIODE LASER SYSTEM  
WITH EXTERNAL CAVITY**

#18/B  
Amdt  
J. McMillan  
8/8/03

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450 on July 15, 2003.

Harry C. Engstrom

(Name of applicant, assignee  
or Registered Representative)



(Signature)

July 15, 2003

(Date of Signature)

08/11/2003 JMCMLLA 00000008 502350 09706088

01 FC:1201

84.00 DA

**AMENDMENT AND REPLY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

07/21/2003 LMDNDIM1 00000056 09706088

01 FC:1201

84.00 DP

In reply to the Patent and Trademark Office Action of June 4, 2003, after entry of the accompanying petition for one-month extension of time extending the time for reply to August 4, 2003, please amend the claims as follows: